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PATENT APPLICATION Attorney Docket No.2322-013 ECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Tae-Ho Jang

Serial No.

10/076,237

Examiner:

Maria F. Guerrero

Filed:

February 13, 2002

Group Art Unit: 2822

Confirmation No. 9968

For:

SILICON-ON-INSULATOR (SOI) SUBSTRATE AND METHOD FOR

MANUFACTURING THE SAME

Assistant Commissioner for Patents Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the Restriction Requirement, dated December 31, 2002, Applicant hereby elects Group 1 (claims 7-18), without traverse.

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, PC

Alan T. McCollom

Registration No. 28,881

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I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS WALL IN AN ENVELOPE ADDRESSED TO:

COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON D.C. 20231

ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON D.C. 20231

ASSISTANT COMMISSIONER FOR TRADEMARKS, 2900 CRYSTAL DRIVE

On 1-24-B